





an Open Access Journal by MDPI

Cyber Physical Production Systems

Guest Editor:

Prof. Dr. Sebastian Thiede

Chair of Manufacturing Systems, Faculty of Engineering Technology, Department of Design, Production & Management, University of Twente, 7522 LW Enschede, The Netherlands

Deadline for manuscript submissions:

closed (31 July 2020)

Message from the Guest Editor

Without a question, digitalization is one of the major trends in manufacturing—typically associated with terms like Industry 4.0, smart factory or industrial internet—and will have a significant influence on the planning and control of future factories. Cyberphysical production systems (CPPS) are the technical core element of this "4th Industrial Revolution". As indicated by the name, CPPS consist of a "physical" and an up-to-date "cyber" subsystem (often referred to as "digital twin") based on continuous data acquisition. With this, decision support or even automatic control functionalities can be enabled CPPS bear significant potential for improvement and can be applied for production machines, process chains or factories as a whole. Examples can be found in the context of process/machine control. maintenance. management, and quality management. However, it is often just singular approaches with a focus on specific CPPS elements or rather conceptual descriptions that can be found so far...

For further reading, please visit mdpi.com/si/34161.











an Open Access Journal by MDPI

Editor-in-Chief

Prof. Dr. Steven Y. Liang

George W. Woodruff School of Mechanical Engineering, Georgia Institute of Technology, Atlanta, GA 30332-0405, USA

Message from the Editor-in-Chief

Journal of Manufacturing and Materials Processing (JMMP) (ISSN 2504-4494) is a new MDPI peer-reviewed, open access venue with a focus on the scientific fundamentals and engineering methodologies of manufacturing and materials processing. We offer an online platform facilitating effective exchange of innovative scientific and engineering ideas and the dissemination of recent, original, and significant research and developmental findings. On behalf of the Editorial Board, I extend an invitation to our scientific and engineering colleagues to contribute high-quality, innovative, and ground-breaking research articles to JMMP.

Author Benefits

Open Access: free for readers, with <u>article processing charges (APC)</u> paid by authors or their institutions

High Visibility: indexed within Scopus, ESCI (Web of Science), Inspec,

CAPlus / SciFinder, and other databases.

Journal Rank: CiteScore - Q1 (Mechanical Engineering)

Contact Us